

Our ref.: KON-2020

Client's ref.: P6636-001-0000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Application of: Hiromoto, II,:
et al

Art Unit: 1792

Appln. No.: 10/544,084

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Examiner: David P.
TUROCY

Filed: July 28, 2005

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For: FILM FORMING METHOD AND
SUBSTRATE HAVING A FILM
FORMED BY THE METHOD

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Dated: September 11, 2009

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Confirmation #9413

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE

I hereby certify that this correspondence is being
EFS-Web or facsimile transmitted to the USPTO or
deposited with the United States Postal Service with
sufficient postage as first class mail in an envelope
addressed to: the Commissioner for Patents, P.O. Box
1450, Alexandria, VA 22313-1450 on September 11,
2009.

LUCAS & MERCANTI, LLP

BY:


Donald C. Lucas, Reg. #31,275

S i r:

This is in response to an Office Action dated June 16, 2009
in this Application. Attached hereto are Claim Amendments, a
Certified English Translation of the Japanese Priority Document
JP 2003-197799 and Remarks, each starting on a separate page.